

**INFORMATION DISCLOSURE
STATEMENT BY APPLICANT PTO-1449**

Docket No.
52433/820

Application No.
10/551,159

Applicant(s)
TANAKA et al.

Examiner
Michael E. Lavilla

Filing Date
September 28, 2005

Confirmation No. Art Unit
3164 1794

U. S. PATENT DOCUMENTS

EXAMINER INITIAL	PATENT/PUBLICATION NUMBER	PATENT/PUBLICATION DATE mm/dd/yyyy	NAME	CLASS	SUBCLASS	FILING DATE

FOREIGN PATENT DOCUMENTS

EXAMINER INITIAL	DOCUMENT NUMBER	DATE mm/dd/yyyy	COUNTRY	CLASS	SUBCLASS	TRANSLATION	
						Yes	No
/JZ/	2001-323355	11/22/2001	JP			Abstract	

OTHER DOCUMENTS

EXAMINER INITIAL	AUTHOR, TITLE, DATE, PERTINENT PAGES, ETC.
/JZ/	Chinese Office Action dated 27 June 2008 issued in corresponding Chinese Application No. 2004800090110.

EXAMINER	DATE CONSIDERED
/John Zimmerman/	10/31/2008
EXAMINER: Initial if citation considered, whether or not citation is in conformance with M.P.E.P. 609; draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.	

ALL REFERENCES CONSIDERED EXCEPT WHERE LINED THROUGH. /JZ/